MVP 900 Series

Automated Optical Inspection for Hybrid Assemblies, Micro-electronics, Packaging and Semiconductor Inspection

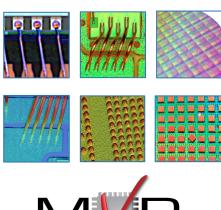


MVP 900 Series

The 900 series is a modular AOI Inspection platform provides a range of advanced optic and handling solutions including 3D, high-resolution imaging and quad color lighting. Camera and optics are scalable to resolutions below 1 Micron. In addition, a range of custom material handling configurations are available including; magazine handling, strip handling, tray handling and wafer handling.

Key Features

- Class 100 Clean Room Options
- High Throughput
- Inspection Capabilities
 - High Resolution 3D
 - Microscopic Objective
 - Hybrid Assemblies
 - 100-300mm Wafer
 - Wafer-Frame
 - Lead-Frame
 - Full Wire-Bond
 - Micro-electronics
 - Packaging





MVP 900 Series

MVP "AOI Elevated"

Motion System X and Y Optical Resolution Optics Optics Camera Optics Illumination 3D Optics 3D Measuring Principle 3D Speed¹ (CM²/s) 3D Sensor X-Y Resolution (um) 3D Sensor Z Repeatability (um)⁵ Max Component Clearance (mm) Software	e Bond, Lead Fra , Ceramics, Thic mal, Epoxy, Glu v you to general without CAD th 0.5 micron pins ² from 0.3-5u 5mp or 12mp te or Quad Colo	osition	, Automotive, BGA, CMM grams with or	
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Max Component Clearance (mm) Software	35		<u>. </u>	
Software				
Offline Program Generation	ePro			
	iPro and Validate			
	AutoData DPC - Sql based data reporting			
. •	Lot Summary R		•	
Optional: AutoData, I	ine integration	to pas	te systems	
CAD and Gerber Inputs Standard, Placement	Standard, Placement, Gerber and ODB++ data import			
Defect Review In-Line or Off-Line	In-Line or Off-Line defect review using iRepair			
Multi-Pass Programmable h	Programmable heights and lighting per pass			
Validate ⁶ Automate	Automated Program Validation			
System				
Computer Dual Xeon Pro	ocessor - Multi-	Thread	ding	
1TB SSD Hard	Drive - 32-2560	B Mer	mory	
Operating System Linux based Multi-Thr	Linux based Multi-Threading CentOS Operating System			
Data Integration Options SECS/G	SECS/GEM, AutoData, DPC			
Networking Full network integ	Full network integration (TCP/IP, NFS Protocol)			
Physical				
	355mm (14") x 355mm (14") ³			
	0.254 - 12.5mm (0.01 - 0.5")			
Clearance Top Sic	Top Side to 50.8mm (2")			
Conveyor Height	SMEMA			
Footprint 844mm (33.25") W x 10	844mm (33.25") W x 1066mm (42") D x 1473mm (58") H			
Conveyor Length 85	850mm (33.46")			
Power 208-240VAC 50/	208-240VAC 50/60Hz, 10A (Optional 110V)			
Air	60 PSI, 1CFM			
Weight 680	680 kgs (1500 lbs.)			
Compliance S2/S8 -	· CE - (UL Optio	nal)		

$^{\mathrm{1}}$ Using standard resolution, quarter range. Scan speed can be increased using larger profile steps.

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MVP 900 Series - Wafer, Die and Wire-Bond Inspection and much more.

Focused on Quality, Metrology and Automation, the 900 series provide automated inspection and measurement solutions to the semiconductor, micro-electronics and high-reliability markets.

MVPs 900 platforms provide the highest resolution 2D & 3D Capabilities and optics for Semiconductor, Micro-electronics, Packaging and CMM.

Using high resolution 3D systems, 12MP cameras, Multi-tier lighting and Multi-pass technology MVPs 900 series can provide the inspection coverage while achieving the required UPH.

MVP's proprietary algorithms allow for inspection and metrology on all Micro-electronics.

Automation is key to the 900's flexibility. Using MVPs integrated magazine, wafer, tray, and cassette handlers the system can provide standardized automation for all processes.



For line integration the 900 series uses SECS/GEM, e-Maps and ELSRs to provide manufacturing data.







Die/Wafer/Surface





Height

Bump/BGA

² Dependent on camera and lens configurations.

³ Please check final chosen configuration and some options can reduce board size.

⁴ Flex Circuits, Non-Rigid boards will require fixturing. 12.5mm is an advisory for board thickness.

 $^{^{\}rm 5}$ Static repeatability using MVP calibration target.

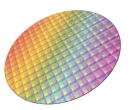
⁶ Program Dependant

MVP 900 Series - Configurations

MVP 900 W - (Wafer 100-300mm)

Manually Loaded Wafer Inspection.

- **Surface Inspection**
- **Bump Inspection**
- Support For 100, 150, 200 and 300mm Wafers



MVP 900 DW - (Film Frame - Diced Wafer)

Manually Loaded Diced Wafer Inspection.

- Surface/Edge Inspection
- **Bump Inspection**
- Support for up-to 15" Frames



MVP 900 ALW - (Wafer 100-300mm)

Automatically Loaded

- Surface, Bump Inspection
- Support For 100, 150, 200 and 300mm Wafers
- 3rd Party Handlers
 - -SMIF, FOUP



MVP 900 ADW - (Film Frame - Diced Wafer)

Automatically Loaded from Cassette.

- Surface/Edge Inspection
- **Bump Inspection**
- Support for up-to 15" Frames with Flipper



MVP 900 DWMS - Die Wire Metrology

Automatic Load from Magazine Loaders

- Lead-Frame Inspection
- Die/Wire Inspection
- Highest throughput
- **Defect Marking**



MVP 900 Mil-Spec - Die and Wire

In-Line or Manual Load

- Wire bond Inspection
- 1.67um Resolution
- Laser Profiler for Loop Height
- **RF Module Inspection**
- Mil-Spec 883



MVP 900 AMS - Automotive Focused

In-Line or Manually loaded

- Wedge Bond Inspection
- **Highest Throughput**
- Laser Profiler for Loop Height
- Full Module Traceability with AutoData.



MVP 900 T and 900 TS - In Tray Inspection

Loaded from Tray Stacker or In-Line

- Available Part Sorter (TS) **BGA** Inspection
- Die Inspection
- JEDEC, Auer, Waffle Tray Support.

